

Application No. 10/567,344

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant : Yoav Paltieli et al.
Appl. No. : 10/567,344
Filed : 6 February 2006
Title : Method And Apparatus For Monitoring Labor Parameters
Group Art Unit: 3737
Examiner : Baisakhi Roy
Docket No. : 1312PAL-US
Honorable Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action of April 13, 2010, please amend the above-identified application as follows: